



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

March 2, 2026	
IGI Report Number	LG779640115
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	OVAL BRILLIANT
Measurements	9.60 X 6.12 X 3.90 MM

GRADING RESULTS

Carat Weight	1.50 CARAT
Color Grade	E
Clarity Grade	VS 2

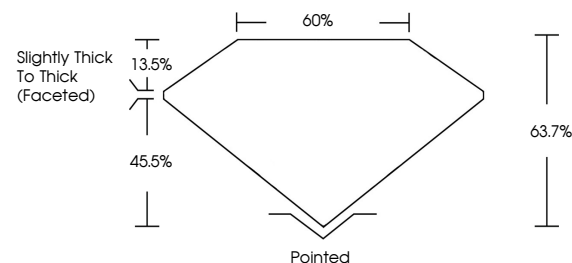
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	151 LG779640115

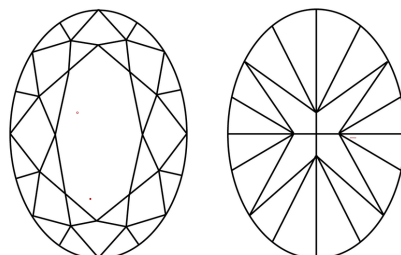
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG779640115
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

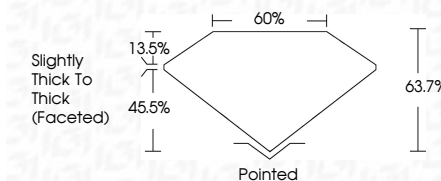
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www.igi.org

March 2, 2026
GI Report No LG779640115
COVAL BRILLIANT

1.50 CARAT	
VS 2	
63.7%	
60%	
Slightly Thick to Thick (graded)	
Pointed	
EXCELLENT	
EXCELLENT	
NONE	
4mm / 127.00/1.15	

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(CVD) growth process.